

## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Vignia 22313-1450 www.uspto.gov



**CONFIRMATION NO. 7111** 

Bib Data Sheet

Douglas M. Reber, St. Ismier, FRANCE;  Mark D. Hall, Austin, TX; Kurt H. Junker, Austin, TX;Kyle W. Patterson, Froges, FRANCE; Tab Allen Stephens, Austin, TX; Edward K. Theiss, Cedar Park, TX; Srikanteswara Dakshiina-Murthy, Wappingers Falls, NY; Marilyn Irene Wright, Sunnyvale, CA;	<b>10</b> .
Mark D. Hall, Austin, TX; Kurt H. Junker, Austin, TX;Kyle W. Patterson, Froges, FRANCE; Tab Allen Stephens, Austin, TX; Edward K. Theiss, Cedar Park, TX; Srikanteswara Dakshiina-Murthy, Wappingers Falls, NY; Marilyn Irene Wright, Sunnyvale, CA;	
Mark D. Hall, Austin, TX; Kurt H. Junker, Austin, TX;Kyle W. Patterson, Froges, FRANCE; Tab Allen Stephens, Austin, TX; Edward K. Theiss, Cedar Park, TX; Srikanteswara Dakshiina-Murthy, Wappingers Falls, NY; Marilyn Irene Wright, Sunnyvale, CA;	
Kurt H. Junker, Austin, TX;Kyle W. Patterson, Froges, FRANCE; Tab Allen Stephens, Austin, TX; Edward K. Theiss, Cedar Park, TX; Srikanteswara Dakshiina-Murthy, Wappingers Falls, NY; Marilyn Irene Wright, Sunnyvale, CA;  ** CONTINUING DATA **********************************	
" CONTINUING DATA	
None	
** FOREIGN APPLICATIONS ************************************	
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/23/2003	
Foreign Priority claimed yes on o STATE OR SHEETS TOTAL INDEPE	NDENT
wet  Verified and Acknowledged  Acknowledged  Allowance  COUNTRY DRAWING CLAIMS CLA  FRANCE 2 27  Examiner's signature Initials  FRANCE 2 27	
ADDRESS 23125 FREESCALE SEMICONDUCTOR, INC. LAW DEPARTMENT 7700 WEST PARMER LANE MD:TX32/PL02 AUSTIN, TX 78729	
TITLE Semiconductor device having an organic anti-reflective coating (ARC) and method therefor	
Semiconductor device having an organic anti-reflective coating (ARC) and method therefor	